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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/532,267	04/22/2005	Pierre Nicolas	112701-600	1492
29157 K&L Gates LLl	7590 07/07/200 P	9	EXAM	IINER
P.O. Box 1135	60600		TRAN LIEN, THUY	
CHICAGO, IL	00090		ART UNIT	PAPER NUMBER
			1794	
			NOTIFICATION DATE	DELIVERY MODE
			07/07/2009	ELECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Notice of the Office communication was sent electronically on above-indicated "Notification Date" to the following e-mail address(es):

chicago.patents@klgates.com

	Application No.	Applicant(s)					
Office Action Comments	10/532,267	NICOLAS ET AL.	NICOLAS ET AL.				
Office Action Summary	Examiner	Art Unit					
	Lien T. Tran	1794					
The MAILING DATE of this communication a Period for Reply	ppears on the cover sheet wit	th the correspondence addr	ess				
A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory perions after the reply within the set or extended period for reply will, by state the provision of the period by the Office later than three months after the main earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNIC 1.136(a). In no event, however, may a re od will apply and will expire SIX (6) MON ute, cause the application to become AB.	CATION. Peply be timely filed THS from the mailing date of this common (and the common control of the control of					
Status							
1) Responsive to communication(s) filed on 21	April 2009.						
·— · · · · · · · · · · · · · · · · · ·	nis action is non-final.						
<i>,</i>	<i>,</i> —						
,	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims							
4)⊠ Claim(s) <u>1,3-9,12-17,19 and 20</u> is/are pendir	ng in the application.						
4a) Of the above claim(s) is/are withdo	4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.							
6)⊠ Claim(s) <u>1,3-9,12-17,19 and 20</u> is/are rejecte	· ·						
7) Claim(s) is/are objected to.							
8) Claim(s) are subject to restriction and	l/or election requirement.						
Application Papers							
9)☐ The specification is objected to by the Exami	ner.						
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage							
application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	Paper No(s	ummary (PTO-413))/Mail Date ıformal Patent Application 					

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Claims 1, 3-9, 12-17, 19-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Pruden et al (US2003/0072862A1) in view Huang et al. (WO 02/39820A2) and applicant's admission of prior art.

Pruden et al disclose a bakery composition comprising at least one enzyme selected from an alpha amylase, protease and pentosanase. Pruden et al teach a method of extending the shelf life of the bakery product by adding the bakery composition to the dough or batter. The dough is baked whereupon the extended shelf life is manifested in the baked product. Nonlimiting useful examples of the bakery products include cookies, biscuit, waffles, pancake, any cereal based food products etc.... The bakery products are made by use of a leavening agent or without leavening agent. The effective amount of the enzyme ranges from about .21-6 parts by weight of the dough. (see paragraphs 0014,0016, 0017, 0027, 0024,0050)

Pruden et al do not disclose wafer having the humidity as claimed, enzyme in units, the origin of the amylase.

Huang et al disclose a wafer having a humidity of 2%. (see page 9)

Applicant discloses on page 6 of the specification that a typical batter used in the manufacture of commercial flat wafer contains 40-50% flour and common formulations may also comprise at least one of the following ingredients: fat, oi, sugar, sodium bicarbonate, yeast etc..

Pruden et al disclose the bakery composition comprising at least one enzyme can be added to many different types of bakery products including cookies, biscuit.

Wafer is known in the art and defined in the dictionary as small, thin flat cookie or

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biscuit. Thus, if the composition is added to cookies, it can be added to wafer because wafer is a type of cookie. It would have been obvious to one skilled in the art to add the composition to wafer when desiring to extend the shelf life of the wafer. The generation of in-situ modified starch and the forming of soluble dextrin is an inherent result from the addition of the enzyme before baking. Wafer is known in the art to have low humidity as shown by Huang et al. When a wafer is formed, it would have been obvious to one skilled in the art to make the wafer to have a humidity that is appropriate for such product. It would also have been obvious to add ingredient such as gassing agent because such additive is conventional for wafer as disclosed in the specification. Page 13 of the specification, the concentration of enzyme can range from .00078-.4%. Pruden discloses the amount of enzyme can be from .21-6 part. The process of forming a wafer is so well known in the art and would have been obvious to one skilled in the art when making a wafer. It would have been obvious to obtain the enzyme from any source; all the sources claimed are well known in the art.

Applicant's arguments with respect to claim1, 3-9,12-17,19-20 have been considered but are most in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lien T. Tran whose telephone number is 571-272-1408. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Keith Hendricks can be reached on 571-272-1401. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

June 30, 2009

/Lien T Tran/

Primary Examiner, Art Unit 1794